Se	arch Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination
10/719,505	OH, IN-HWAN
Examiner	Art Unit
MATTHEWAY NOUVEN	2020

SEARCHED				
Class	Subclass	Date	Examiner	
363	20 21.01	12/7/2005	MN	
	21.04			
	21.05			
_	21.07			
	21.1			
	21.13			
	31.15			
	21.18	<i>\\</i>	1	

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
EAST: see search history printout	12/7/2005	MN
Interference Search: see search history printout	12/7/2005	MN